



Image AF/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tyler A. Lowrey § Art Unit: 2814  
§  
Serial No.: 09/944,478 § Examiner: Tuan N. Quach  
§  
Filed: August 31, 2001 §  
For: Elevated Pore Phase- § Docket: ITO.0506US  
Change Memory § P12499  
§

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Please  
enter  
TU  
3/25/04

Sir:

**REPLY TO FINAL REJECTION**

In response to the final rejection mailed February 12, 2004, reconsideration is requested in view of the following remarks.

Date of Deposit: <u>March 2, 2004</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
<u>Cynthia L. Hayden</u> Cynthia L. Hayden